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PATENT
ATTORNEY DOCKET NO.: 049128-5144

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Byung Chul AHN, et al.) Confirmation No.: 8591
Application No.: 10/774,701) Group Art Unit: 2879
Filed: February 10, 2004) Examiner: Patel, V.
For: METHOD OF PATTERNING)
TRANSPARENT CONDUCTIVE FILM,)
THIN FILM TRANSISTOR SUBSTRATE)
USING THE SAME AND)
FABRICATING METHOD THEREOF)

Commissioner for Patents
Customer Window
Alexandria, VA 22314

Sir:

**SECOND INFORMATION
DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)**

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the attached document. To the best of the undersigned's knowledge, this Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application, and no fees are believed to be necessary.

The listed document was cited in a Korean Office Action dated January 13, 2006. A copy of the Korean Office Action along with the listed document is attached.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed document is material or constitutes "Prior Art." If it should be determined that the listed document does not constitute "Prior Art" under

United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of the document.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application. If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 50-0310.

Respectfully submitted,

MORGAN, LEWIS & BOCKIUS LLP

By:



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Dated: February 27, 2006

CUSTOMER NO. 009629

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INFORMATION DISCLOSURE CITATIONAttorney Docket No. :
049128-5144

Application No.: 10/744,701

(Use several sheets if necessary)

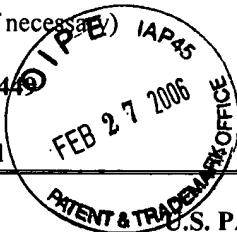
PTO Form 1449

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Applicants: Byung Chul AHN, et al.

Confirmation No.: 8591

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**U.S. PATENT DOCUMENTS**

*Examiner Initial		Document Number	Date	Name	Class	Sub Class	Filing Date

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub Class	<u>Translation</u>	YES	NO
		10-2001-0066262 A	July 11, 2001	Korea			Abstract		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.